

GP 2814

SEC.636
09/313,659

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Won-suk YANG et al.

Serial No.: 09/313,659

Filed: May 18, 1999

For: METHOD FOR FABRICATING A SEMICONDUCTOR DEVICE



Group: 2814

Examiner: S. Rao

7/Decl.
11/22/00
Surles

LETTER

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Enclosed herewith is a copies of Assignment and Declaration and Power of Attorney including the original signatures. Please make these a part of the record of the present application.

Respectfully submitted,

JONES VOLENTINE, L.L.C.

By 

Brian C. Altmiller
Reg. No. 37,271

Date: November 15, 2000

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